

<b>Notice of References Cited</b>	Application/Control No. 10/552,776		Applicant(s)/Patent Under Reexamination NIJBOER ET AL.	
	Examiner Kim-Kwok CHU		Art Unit 2627	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-6,529,458	03-2003	Shin, Jong In	369/53.17
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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